Sheet 1 of 6

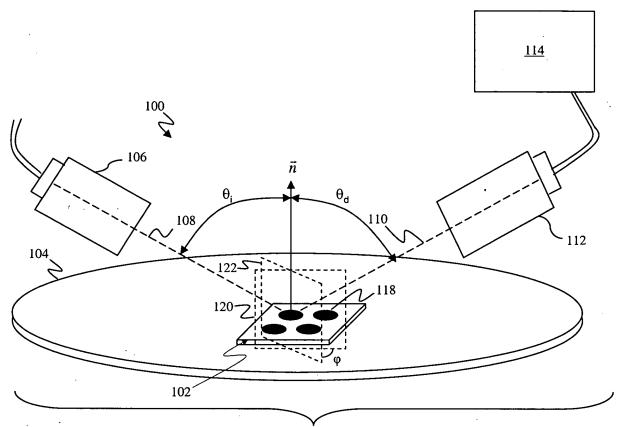
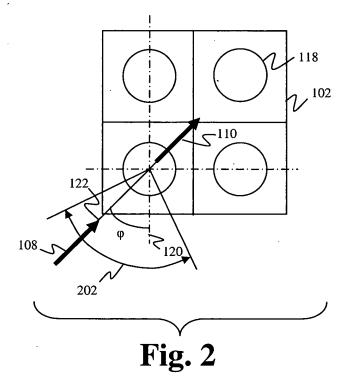


Fig. 1



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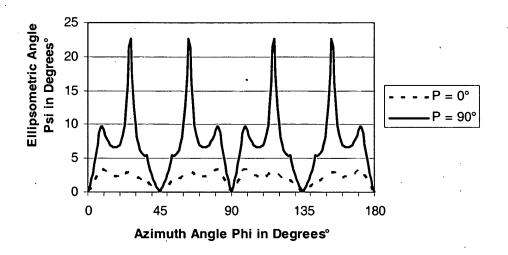


Fig. 3

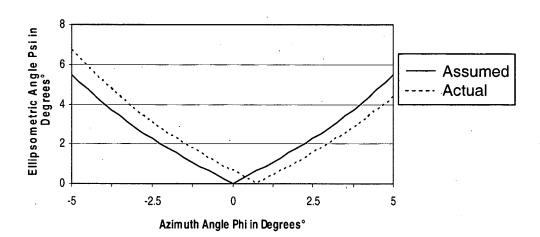


Fig. 4

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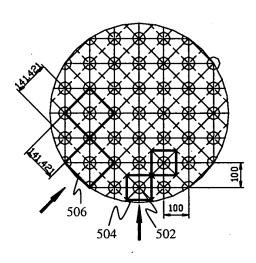


Fig. 5-A

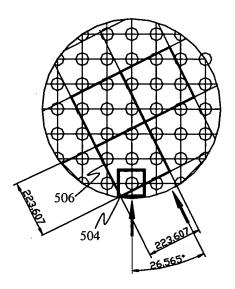


Fig. 5-B

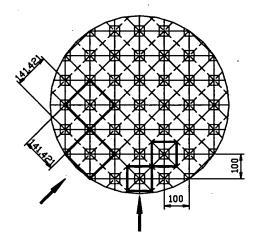


Fig. 5-C

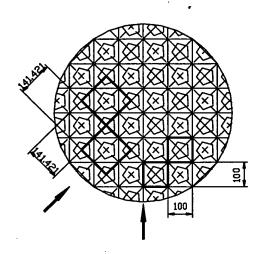


Fig. 5-D

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Application No.: To Be Assigned

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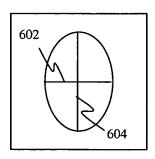


Fig. 6

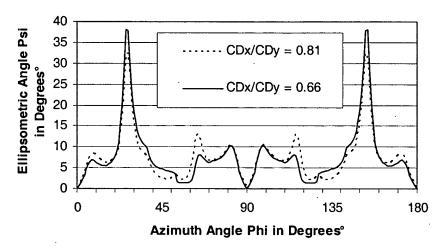


Fig. 7

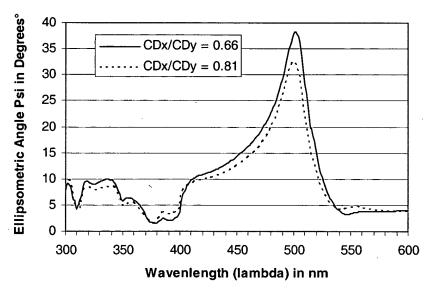
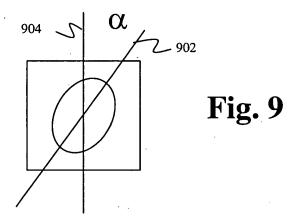


Fig. 8

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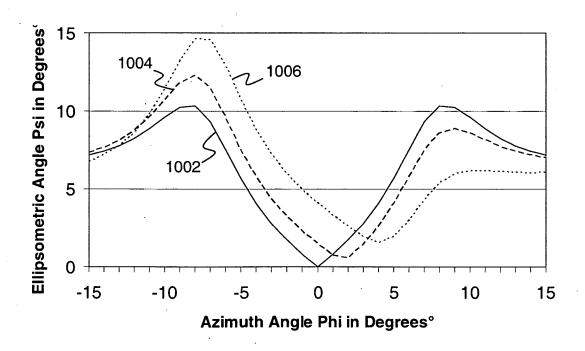


Fig. 10

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